

JP2005000297 13 JUL 2006

033082M336

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yasuo Kobayashi, et al.

International Application No.: PCT/JP2005/000297

International Filing Date: January 13, 2005

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: MANUFACTURING METHOD OF SEMICONDUCTOR
DEVICE AND FILM DEPOSITION SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the International Search Report (ISR) filed herewith. According to the search report, U.S. Patent No. 6,149,730 is a family member of JP 11-176820, U.S. Patent No. 6,429,518 is a family member of JP2000-114252, and U.S. Patent Nos. 5,698,901 and 6,033,979 are family members of JP 8-236517. Copies of the non-U.S. cited documents are enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By:



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July 13, 2006

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M336	SERIAL NO. 3117585994 To Be Assigned
	APPLICANT: Yasuo Kobayashi, et al.	
	FILING DATE Herewith	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA	6,149,730	11/21/00	Matsubara, et al.			
	AB	6,429,518	8/6/02	Endo			
	AC	5,698,901	12/16/97	Endo			
	AD	6,033,979	3/7/00	Endo			
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AH	11-176820	7/2/99	Japan			Abstract	
	AI	2000-223485	8/11/00	Japan			Abstract	
	AJ	2000-114252	4/21/00	Japan			Abstract	
	AK	2000-068261	3/3/00	Japan			Abstract	
	AL	09-237783	9/9/97	Japan			Abstract	
	AM	08-236517	9/13/96	Japan			Abstract	
	AN							
	AO							
	AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AQ	
	AR	
	AS	

EXAMINER:	DATE CONSIDERED:
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.